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	Filing Date		2006-06-20
	First Named Inventor	Peter Dirksen	
	Art Unit	<del>4705</del> 10596647 - GAU: 1721	
	Examiner Name	Thorl Chea	
	Attorney Docket Number	NL040617US1	

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	4	5373806		1994-12-20	LOGAR	
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	1	<del>Yusuke Takano et al, "Top Antireflective Coating Process for 103nm Lithography", 1D-6-7-AZ Electronic Materials/Clariant, Japan; Taiwan Semiconductor Manufacturing Co., Taiwan, R.O.C. XP405774081, Page 136</del> No date of publication provided.	<input type="checkbox"/>
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